O find the conductivity and resistivity of an interior semiconductor at temperature of 300°K. It is given that $n_i = 2.5 \times 10^{13}/\text{cm}^3$ Mn = 3800 cm²/V-s

Mp = 1800 cm²/V-s

9 = 1.6 × 10-19 C

5014 0; = n; e (Me + Mn) = 2.5 × 10¹³ × 1.6 × 10⁻¹⁹ (3,850 + 1800) = 0.0224 S/cm.

germanium at 300° k is 0.47.2-m.

The electron mobility at 300° k
in germanium is 0.39 m 2/15.

The hole mobility un at 300° k
in germanium is 0.19 m²/1.5.

The hole mobility un at 300° k
in germanium is 0.19 m²/1.5.

The elect Calculate the density
of electrons in the intrinsic
material. Also calculate the
drift velocity of holes and
electrons for an electric field
(E=101, V/m).

intrinsic resistivity (Pi) = 0.47 R-m intrinsic conductivity (0;) = p = 1 = 2-12766 S/m $Mc = 0.39 \text{ m}^2/V-s$ $Mn = 0.19 \text{ m}^2/Vs$ e = 1.6 ×10-19 C Oi= hie (Met Mh) no= Oi e(ue+lin) = 2.12766 1.6×1519(0.39.40.19) n= = 2.293 × 109/ m3 Ans E= 104 V/m Vn= MeE = 0.39×104

Un = 3900 m/s ANS

Wh = 3900 m/s ANS

Wh = 4h = 6.19 × 104

Wh = 1900 m/s ANS

(3) The intrinsic carrier Concentra-- Hion for silicon at roomtemp. 10 1.5×10 /cm3. If the mob. - ility of electrons and hales are 1300 cm2/v-s and 450 cm2/vs respectively. what is the condu-- ctivily of silicom (intrinsic) at 300 kg If silicon is doped with 1016 boron atoms perec, what is its conductivity. == n== 1.5 x10 /cm3 Mh = 450 cm2/V-s

Me = 1300 cm2/V-s Of= nie (Me+Mh) = 1.5 x10 x1.6 x10 19 (1300 + 450) 0; = 4.2 ×10-6 S/cm.) ANS.

After Dobing NA = 1018/cm3

Op = NAC Mh = 1018 X1.6 X1019 X 450 Op = 72 S/cm Ans.

(4) find the conductivity of intrinsic germanium at 300°K. If donor type impurity is added to the extent of 1 impurity atom in 107 germanium atoms, find the conductivity. Giver that

Mi= 2.5 × 10 13/cm3 Mh = 1800 cmy V-S Me = 3800 cm2/v3

Concentration of Gre outoms = 4.41 X1022/cin

Sol Op = hee (He+ Mh) = 2.5×10×1.6×1519 (3800+1800)

σρ = 0.0224 S/cm ANS.

ANO. of the atoms/cm3=4.41×102/cm3 ND = 4.41×1022 - 4.41×10 5/cm3 Concentration of electrons. 12ND= 4.41×1015/cm3

 $P = \frac{m_0^2}{ND} = \frac{(2.5 \times 10^{13})^2}{4.41 \times 10^{15}}$

P= 1.417×10"/cm3

OE= enome = 1.6x10 9x 4.41x10 5x3800

OE = 2-68 S/cm/ Aous

A pd (Potential difference) of 10V is applied longitudinally to a rectangular specimen of intrinsic Ge of laugh 25 mm, width 4 mm and Hickness 1-5 mm. Determine at roomtenp. (i) electron and have drift relocities. (11) the conductivity of intrinsic germanium if intrinsse carrier mily is 2-5×1019/m3 (iii) Total current.

M Giren! He= 0.38 x 2 1/2, 4n= 0.18 m/ks 1) 6= 1/2 = 10 0.025 = 400 V/m. Vc= He KE = 0.38 X400 (Ue = 152 m/s / Done Un = Mn XE = 0.18 × 400 1 Un= 72 m/s/ ANS (il) O:= hie (Met lun) = 2-5×10 19×1.6×1519.(0.38+0.18) OF = 2.24 S/m/ ANS (iii) I = O, Ea

= 2.24 × 450 × 4×153 × 1.5×153 = 5.376 mA) Ans

Tutorial - I

1) In a certain copper conductor, the current density is 2.4 A/mm² and electron density is 5 x 1028 free electrons per m3 of the copper. Determine the drift velocity of the electrons.

J=2.4 A/mm2 = 2.4 × 106 A/m2

(dorgeon electron) q = 1.6 × 10 19 C

J = @n 90 $9 = \frac{1}{nq} = \frac{2.4 \times 10^6}{1.6 \times 10^{-19} \times 5 \times 10^{28}}$

(2) A conductor material has a free electron density of 1024 electrons per m3. When a valtage is applied, a constant drift relocity of 1.5×10-2m/s is attained by the electron. If the cross-sectional area of the mediane area of the mertenal is 1 em² calculate the magnitude of current. Exemp

9 = 1.6×10-19 C.

U=1.5×10-2 m/s=0.015 m/s] J=0

a= 1 cm2 = 1×10-4 m2 9nva = 1.6×10-19×1024×0.015×1×10-4 /9129 · magnitude of I) = = 0.24 A ANS

J=ngv=nev,

I = hera

nguE

3. A specimen of germanium at 300 k for which the densite of carriers is 2.5 × 1013 per cm3, is doped with impurity atoms such that there is one impurity atom for 10 germanium atoms. All the impurity atoms may be assumed ionized. The conductivity of doped material is 25.64 5/2m. Currier mobility for germanium at 300 k is 3600 cm/vs. Currier mobility for germanium at 300 k is 3600 cm/vs. have doped material, find the electron and have density.

501 $\sigma = 25.64 \frac{56m}{5m} \frac{5cm}{5cm}$ charge on electron $(9) = 1.602 \times 10^{-19} c$.

mobility M== 3600 cm²/V-s

On = ng/e = ND que - D

 $N_D = \frac{\sigma_n}{q_1 Me} = \frac{25.64}{1.662 \times 10^{19} \times 3600}$

= 4.45 ×1016/cm3

(i) Concentration of electron n2HD=4.45 X10 /cm3

(ii) Concentration of hole, P = not = (2.5 ×1013)2.

= 1.4 ×1010 /cm3

Ans

- (4) A donor type impurity is added to the extent of 1 atom per 106 atoms of an intrinsic semiconductor (Silicon). Calculate (1) Resulting donor atom concentration (ii) Resulting mobile electron concentration (iii) Resulting hole concentration. (iv) conductivity of doped silicon sample. (V) If silicon bar is 0.5 cm long, cross-section area of (50×10-4) cm2. Find its resistivity. Concertation of vilicon atoms = 5×1022 cm-3 Solⁿ and silicon $Me = 1.45 \times 10^{16}$ cm⁻³

 Solⁿ

 (i) $N_D = (no. \text{ of silicon atom Kem3}) \times (\text{donor impurity})$ = 5 × 10²² × \frac{1}{106} = 5 × 16¹⁶ / cm³ ANS (ii) Mobile electron concentration $n \simeq ND = 5 \times 10^{16} / cm^3 ANS$.

 (iii) Hole concentration $p = \frac{n^2}{ND} = \frac{(1.45 \times 10^{10})^2}{5 \times 10^{16}} = 4.205 \times 10^3$ per cm³
 ANS (IV) Conductivity of doped silicon σ=ngμe = 5×10 ×1.602×1519×1300 = 10.413 5/εμ (v) Resistivity $p = \frac{1}{6} = \frac{1}{10.413} = 0.096 \Omega \cdot cm$
 - Resistance y given semiconductor $R = \frac{Pl}{\alpha} = \frac{0.096 \times 0.5}{(50 \times 10^{7})^{2}} = 1920.92$ ANS